



8-30-02

2813

#15/Changes
9/18/02
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ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE
Serial No.: 09/614,286
Filed: July 12, 2000
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner: Timothy J. Sutton
Group Art Unit: 2813
Assistant Commission for Patents
Washington, D.C. 20231

CHANGE IN CORRESPONDENCE ADDRESS

S I R :

It is respectfully requested that any future correspondence regarding the above-referenced application be directed to Applicant's attorneys (previously appointed) at the following new correspondence address:

Katten Muchin Zavis Rosenman
575 Madison Avenue
New York, New York 10022
Phone: (212) 940-8800
Fax: (212) 940-8986 or (212) 940-8987

Any inquiries regarding this change in address may be directed to the Applicant's undersigned attorney at the above-referenced telephone numbers.

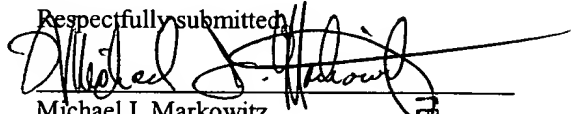
Our CUSTOMER NUMBER 026304 remains the same.

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DOCKET NO.: NECK 17.522

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Respectfully submitted,


Michael I. Markowitz
Reg. No. 30,659

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